Search Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination
10/708,847	YAN, HAI
Examiner	Art Unit
Helen C. Kwok	2856

	SEARCHED		
	JLAN	CHLD	· · · · · · · · · · · · · · · · · · ·
Class	Subclass	Date	Examiner
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
73	504.04	3/22/2005	. HK
73	504.14	3/22/2005	НК
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SEARCH N (INCLUDING SEAR)		<u>')</u>
	DATE	EXMR
Updated Previous Search	3/22/2005	НК
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